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E. R. Witt
Attorney for Applicants

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/614,465 Confirmation No.: 7607
Applicants : Tehsin Lee et al.
Title : METHOD AND SYSTEM FOR POST-TREATING DRY-ETCHED METAL FILM
Filed : July 7, 2003
TC/A.U. : 1763
Examiner : Roberts P. Culbert
Docket No. : 3304.2.66
Customer No. : 21552

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

This paper is submitted in response to the Election/Restriction Requirement mailed January 12, 2005. Applicants elect the invention of Group I, claims 1-15. If the Examiner requires any further information he is requested to contact the undersigned.

Respectfully submitted,

E. R. Witt

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Date: February 9, 2005

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